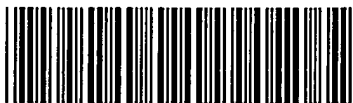


Search Notes

Application/Control No.

10/646,823

Examiner

Hai L. Nguyen

Applicant(s)/Patent under
Reexamination

ISHIMI, KOICHI

Art Unit

2816

SEARCHED

Class	Subclass	Date	Examiner
327	116,119, 146,147, 149,151, 158	4/17/2005	HLN
	153-156		
	160-163		
	291-294		
331	25,34,53		
-	DIG.2		
375	373-376		

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
Search	Above	4/17/2005	HLN

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Shepardize Search	4/17/2005	HLN